

Lithographic Trajectory Planning for Residual Vibration Suppression: An Asymmetric S-Curve Method

Li Li (Associate Professor)
Harbin Institute of Technology



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1. Lithography and Motion Control

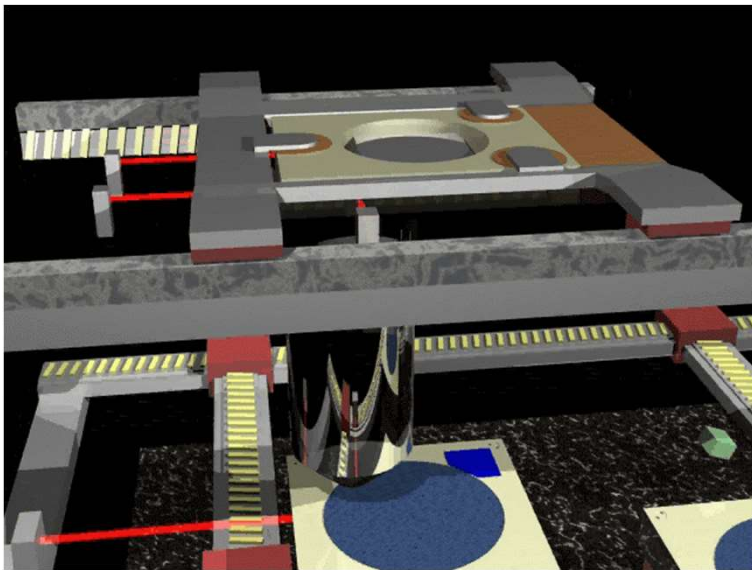
□ **Lithography Tool: CD, Overlay, Throughput**

□ **Wafer & Reticle Stages: MSD, MA, ST**

MSD: High-frequency component of synchronization error, $MSD < 7\text{nm}@CD < 38\text{nm}$

MA: Low-frequency component of synchronization error, $MA < 1\text{nm}@Overlay < 4\text{nm}$

ST: settling time (constant velocity phase, positioning phase), $ST < 10\text{ms}$



Very high dynamic motion

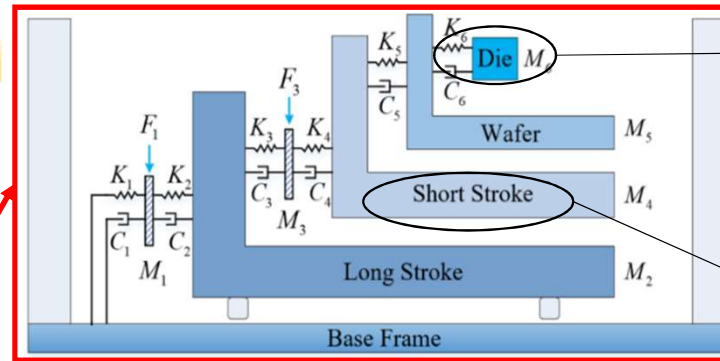
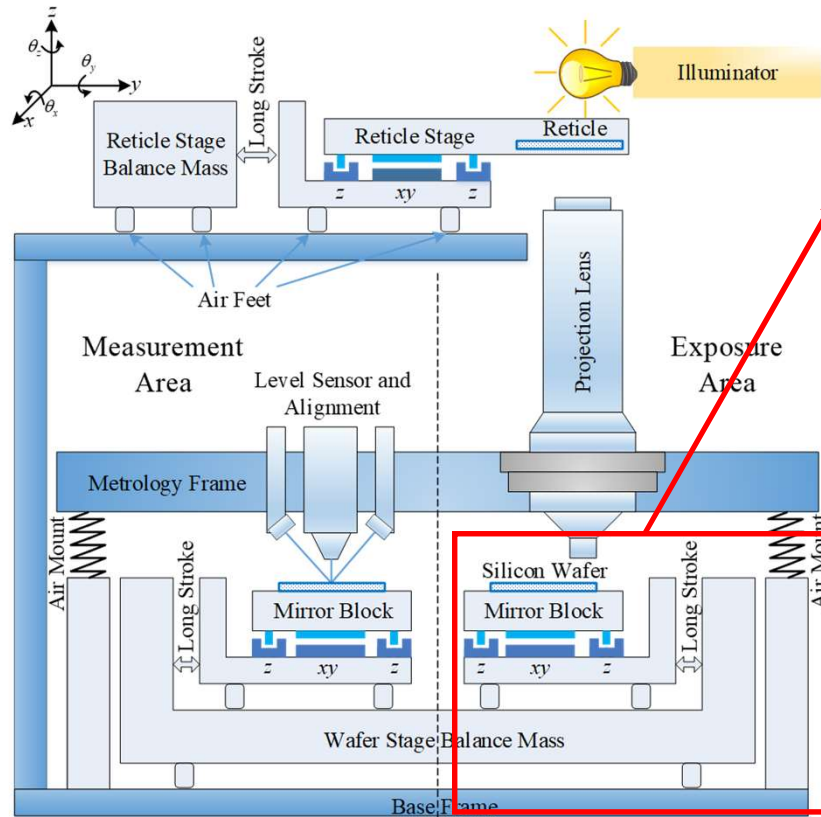
High speed: $V_{\max} = 0.7\text{m/s}$

High acceleration: $A_{\max} = 25\text{m/s}^2$

Very high servo accuracy

Very short settling time

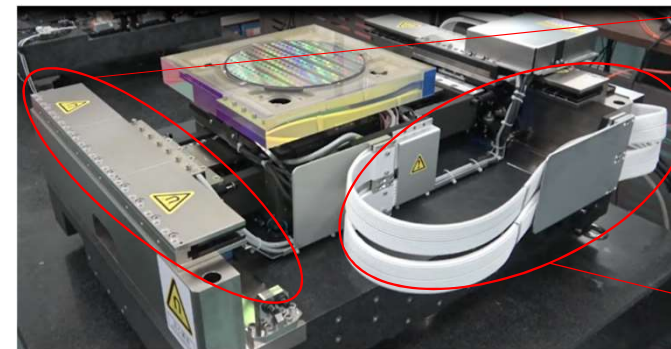
1. Lithography and Motion Control



Point of interest

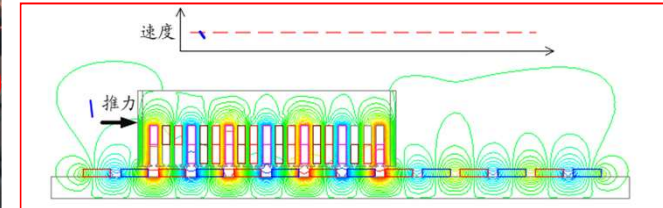
Multi-rigid-body system

Measured and actively controlled point



Magnetic disturbance

Cable force

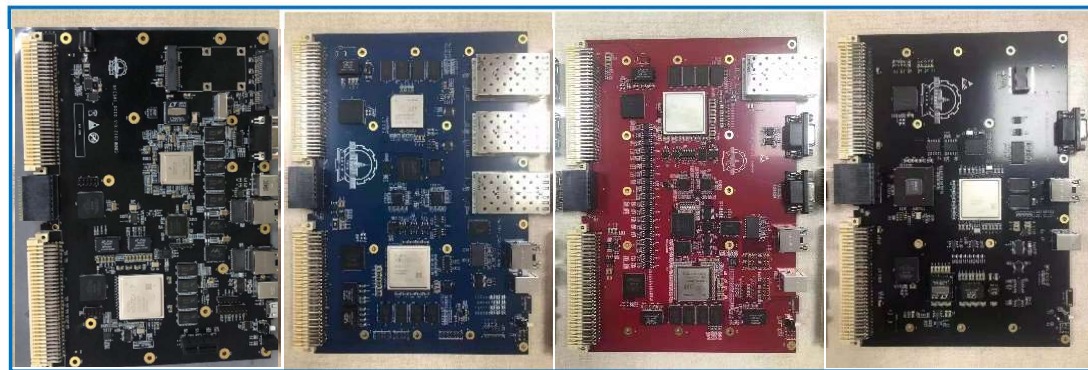


Large amount of sensors (interferometers, eddy current sensors, linear encoders ...)
 Large amount of actuators (planar motors, voice coil motors, linear motors ...)

Very complex measurement & control system

1. Lithography and Motion Control

□ Motion Control System: Hardware & Software



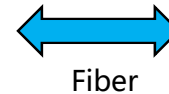
SCB

MCB

SCB

DEB

VME&RSIO Bus



Fiber

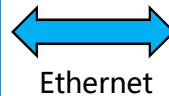


AD

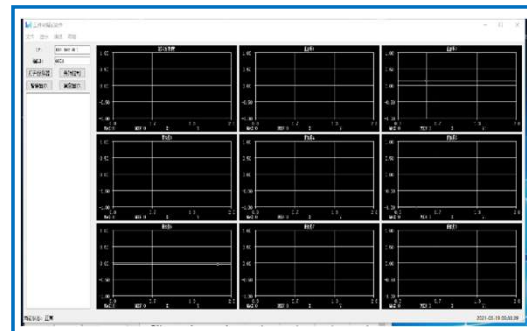
DA



Motion control system



Ethernet



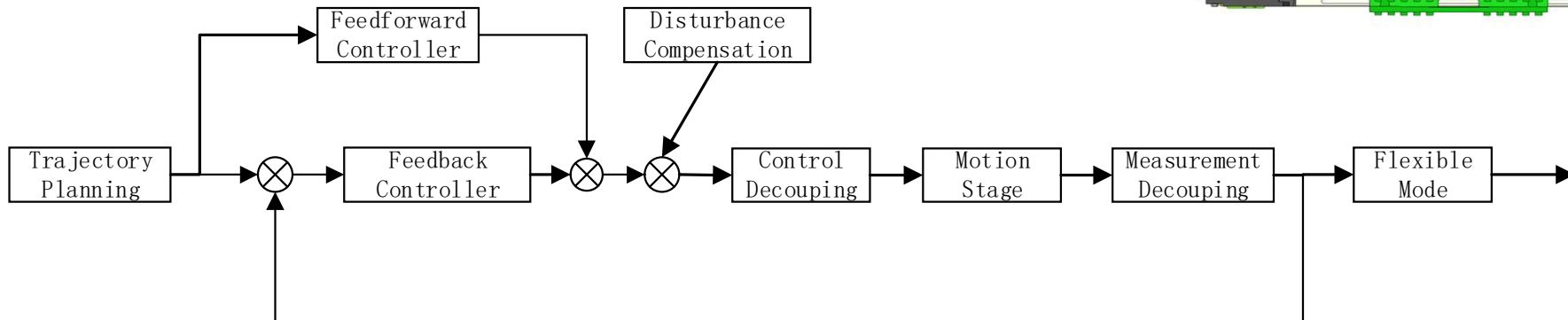
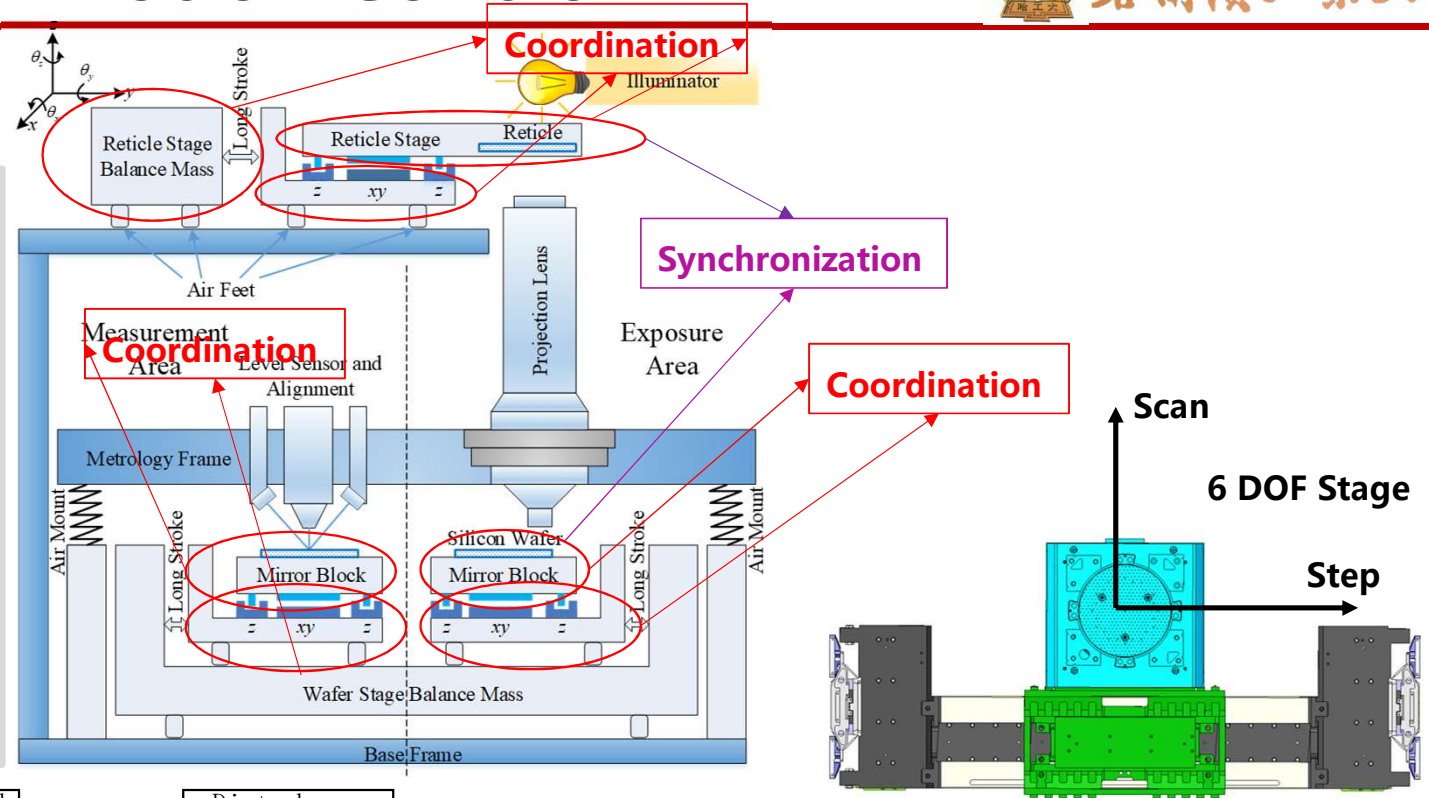
Software

- ✓ Multi-task scheduling
- ✓ Multi-axis coordination
- ✓ Sensor data acquisition
- ✓ Control computation
- ✓ Actuator command transmission

1. Lithography and Motion Control

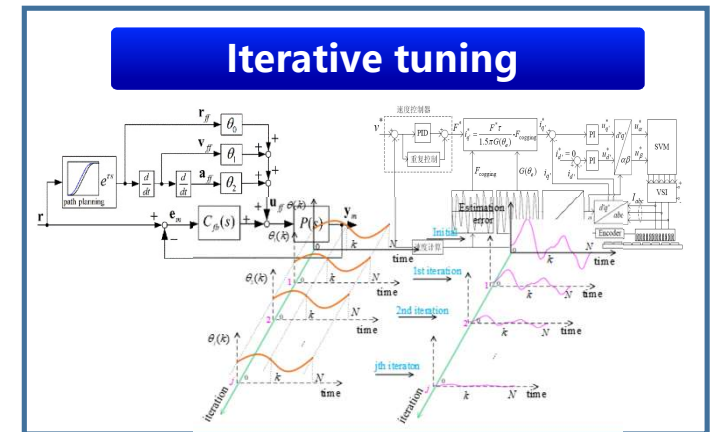
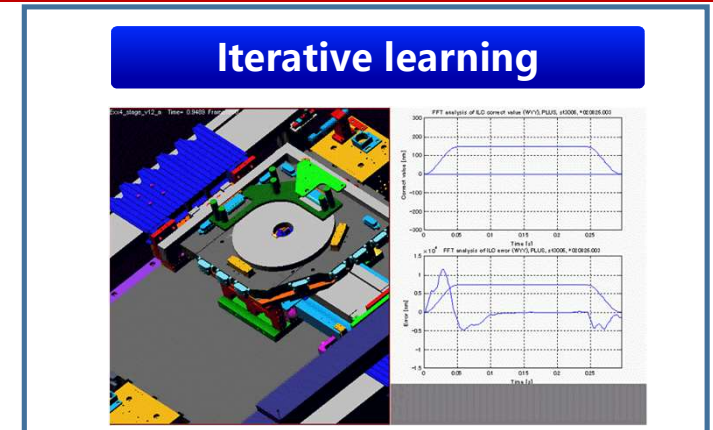
□ Firmware

- ✓ Multi-stage coordination
- ✓ Multi-DOF decoupling
- ✓ Feedback control
- ✓ Feedforward control
- ✓ Disturbance compensation
- ✓ Iterative tuning & learning
- ✓ **Trajectory planning**



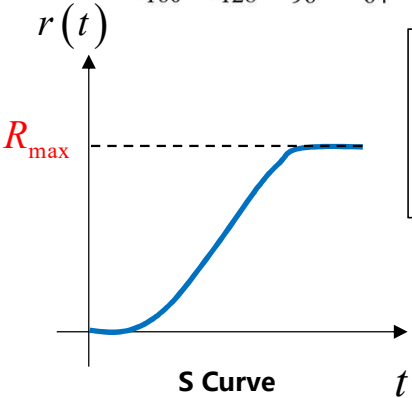
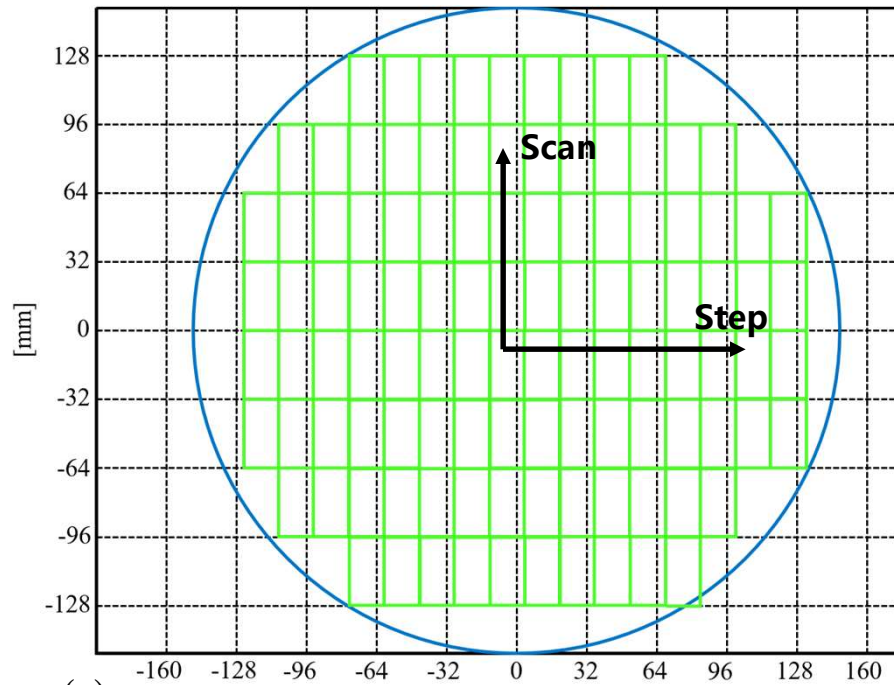
1. Lithography and Motion Control

- [1] Zhao H, **Li L***, Liu Y. Iterative Control Decoupling Tuning by Feedforward Compensation for Precision Motion Stage[C]//2023 IEEE 12th Data Driven Control and Learning Systems Conference (DDCLS). IEEE, 2023: 1812-1817. Oral presentation
- [2] **Li L**, Zhao H, Song F. Enhancing projection based iterative learning control: A set-membership approach[J]. ISA transactions, 2023, 10.1016/j.isatra.2023.06.032. **Top, JCR Q1, IF=7.3**
- [3] Song F, **Li L***, Liu Y, et al. Singular value decomposition based learning identification for linear time-varying systems: From recursion to iteration[J]. International Journal of Robust and Nonlinear Control, 2023,32(12): 6986-7003. JCR Q1, IF=3.9
- [4] **Li L**, Zhao H, Liu Y. Self-Tuning Nonlinear Iterative Learning for a Precision Testing Stage: A Set-Membership Approach[J]. **IEEE Transactions on Industrial Informatics**, 2023,19(7):7995-8006. **Top, JCR Q1, IF=12.3**
- [5] **Li L**, Liu Y, Fu X, et al. Finite time stable inversion in discrete frequency domain: Accuracy analysis, improvement and application to wafer stage[J]. ISA transactions, 2023, 132: 462-476. **Top, JCR Q1, IF=7.3**
- [6] Liu Y, **Li Li**, Chen S, Tan J. Data and mechanism hybrid driven intelligent ultra-precision technology [C]// IFMI & ISPEMI 2022. **Invited presentation**
- [7] 刘杨, **李理***, 陈思文, 等. 面向IC光刻的超精密运动台控制技术[J]. 激光与光电子学进展, 2022, 59(09): 233-253. **Invited survey.**
- [8] **Li L**, Liu Y, Li L, et al. Kalman-filtering-based iterative feedforward tuning in presence of stochastic noise: With application to a wafer stage[J]. **IEEE Transactions on Industrial Informatics**, 2019, 15(11): 5816-5826. **Top, JCR Q1, IF=12.3**
- [9] **Li L**, Liu Y, Yang Z, et al. Method to improve convergence performance of iterative learning control systems with bounded noise[J]. Journal of the Franklin Institute, 2020, 357(3): 1644-1670. **JCR Q1, IF=4.1**
- [10] **Li L**, Liu Y, Yang Z, et al. Mean-square error constrained approach to robust stochastic iterative learning control[J]. IET Control Theory & Applications, 2018, 12(1): 38-44. **JCR Q1, IF=2.6**

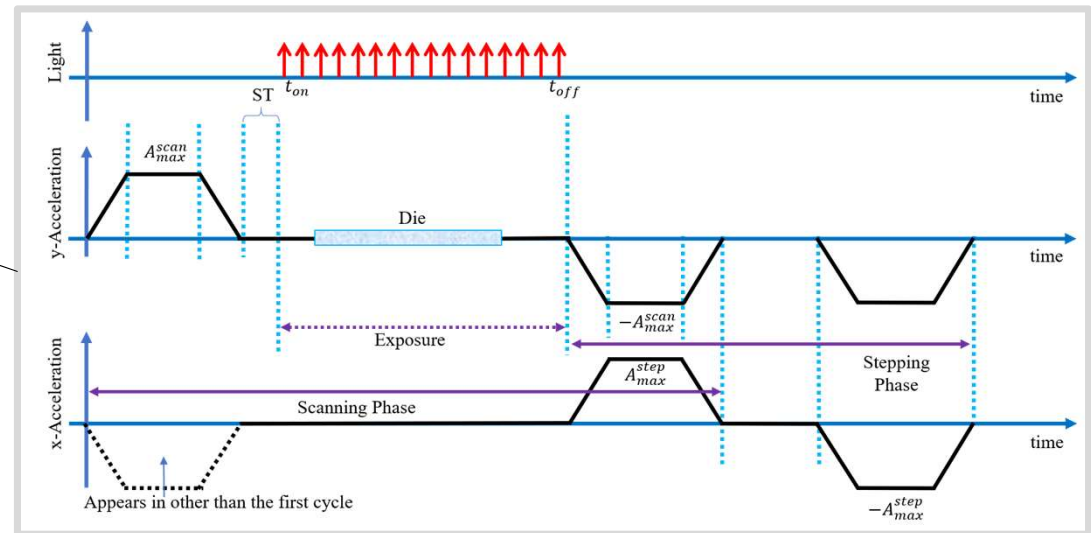
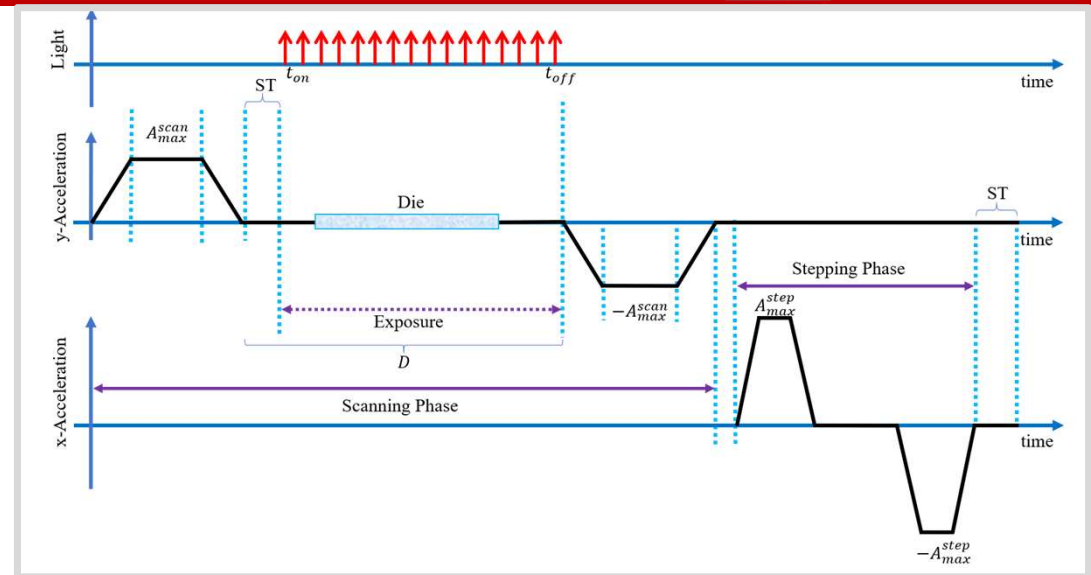


4 top journal paper
1 invited presentation
1 invited survey paper

2. Step & Scan Trajectory



Allow to adjust the trajectory to realize higher performance without increasing total time



3. Symmetric S-curve Planning



Time-domain representations of symmetric S-curves

3rd order S-curve : 7 time intervals can be defined from *JerK* profile

$$t_1 = t_3 = t_5 = t_7 = \frac{A_{\max}}{J_{\max}}, \quad t_2 = t_6 = \frac{V_{\max}}{A_{\max}} - t_1, \quad t_4 \approx \frac{R_{\max}}{V_{\max}} - t_2 - 2t_1$$

4th order S-curve : 15 time intervals can be defined from *Snap* profile

$$t_1 = t_3 = t_5 = t_7 = t_9 = t_{11} = t_{13} = t_{15} = \frac{J_{\max}}{S_{\max}}, \quad t_2 = t_6 = t_{10} = t_{14} = \frac{A_{\max}}{J_{\max}} - t_1,$$

$$t_4 = t_{12} \approx \frac{V_{\max}}{A_{\max}} - 2t_1 - t_2, \quad t_8 \approx \frac{R_{\max}}{V_{\max}} - t_4 - 2t_2 - 4t_1$$

5th order S-curve : 31 time intervals can be defined from *Crackle* profile

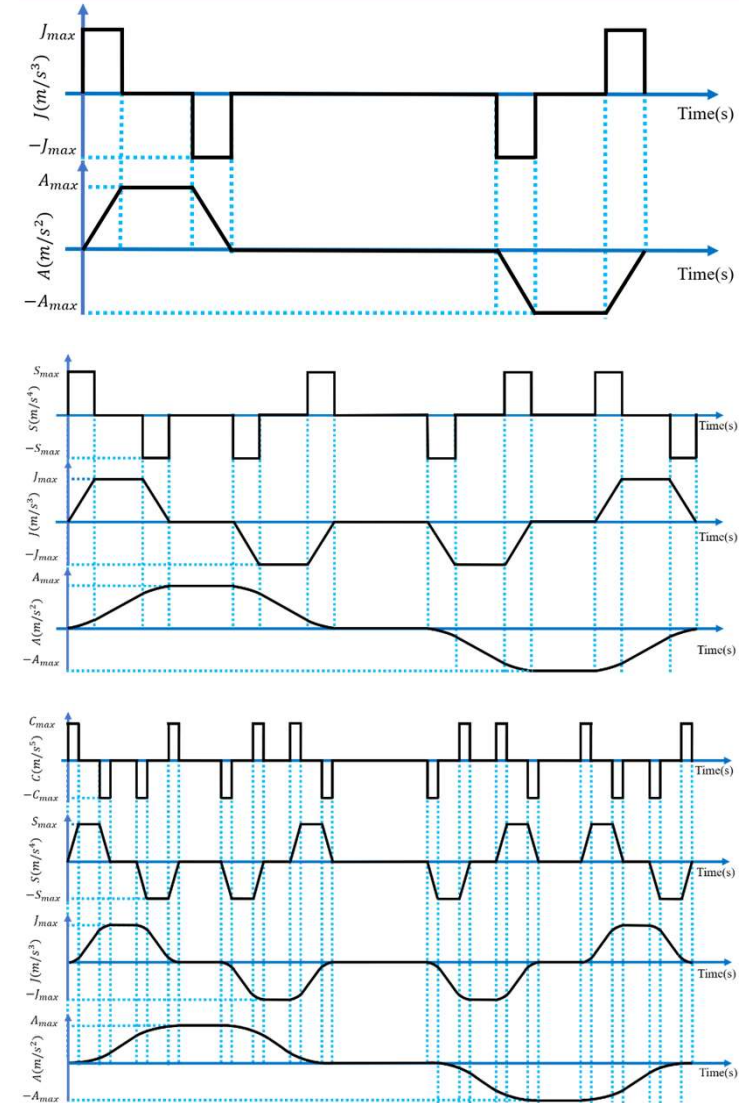
$$t_1 = t_3 = t_5 = t_7 = t_9 = t_{11} = t_{13} = t_{15} = t_{17} = t_{19} = t_{21} = t_{23} = t_{25} = t_{27} = t_{29} = t_{31} = \frac{S_{\max}}{C_{\max}},$$

$$t_2 = t_6 = t_{10} = t_{14} = t_{18} = t_{22} = t_{26} = t_{30} = \frac{J_{\max}}{S_{\max}} - t_1, \quad t_4 = t_{12} = t_{20} = t_{28} \approx \frac{A_{\max}}{J_{\max}} - 2t_1 - t_2,$$

$$t_8 = t_{24} \approx \frac{V_{\max}}{A_{\max}} - t_4 - 2t_2 - 4t_1, \quad t_{16} \approx \frac{S_{\max}}{V_{\max}} - t_8 - 2t_4 - 4t_2 - 8t_1,$$

Conclusions:

- ① q^{th} order S-curve: q times integration of square wave
- ② Time intervals are determined by *trajectory parameters*

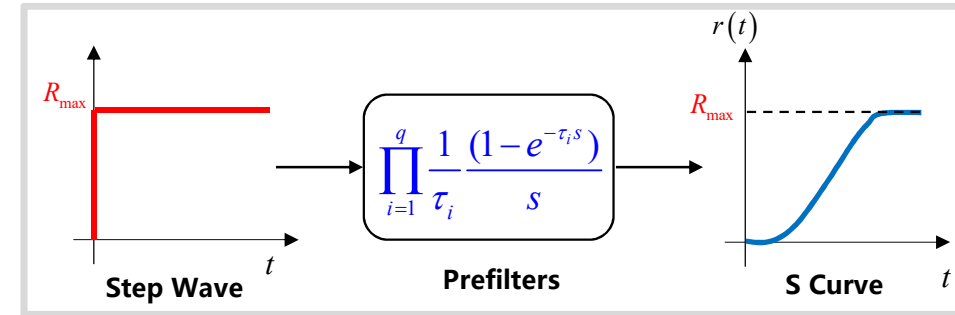


3. Symmetric S-curve Planning



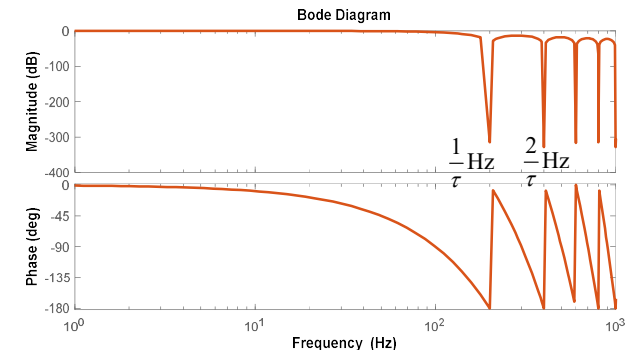
Laplace transformations of symmetric S-curves

$$\begin{aligned}
 3^{\text{rd}} \text{ order : } R(s) &= \frac{J_{\max}}{s} \frac{(1 - e^{-A_{\max}/J_{\max}s})(1 - e^{-V_{\max}/A_{\max}s})(1 - e^{-R_{\max}/V_{\max}s})}{s^3} \\
 &= \frac{R_{\max}}{s} \left(\frac{J_{\max}}{A_{\max}} \frac{1 - e^{-A_{\max}/J_{\max}s}}{s} \right) \left(\frac{A_{\max}}{V_{\max}} \frac{1 - e^{-V_{\max}/A_{\max}s}}{s} \right) \left(\frac{V_{\max}}{R_{\max}} \frac{1 - e^{-R_{\max}/V_{\max}s}}{s} \right) \\
 4^{\text{th}} \text{ order : } R(s) &= \frac{S_{\max}}{s} \frac{(1 - e^{-J_{\max}/S_{\max}s})(1 - e^{-A_{\max}/J_{\max}s})(1 - e^{-V_{\max}/A_{\max}s})(1 - e^{-R_{\max}/V_{\max}s})}{s^4} \\
 &= \frac{R_{\max}}{s} \left(\frac{S_{\max}}{J_{\max}} \frac{1 - e^{-J_{\max}/S_{\max}s}}{s} \right) \left(\frac{J_{\max}}{A_{\max}} \frac{1 - e^{-A_{\max}/J_{\max}s}}{s} \right) \left(\frac{A_{\max}}{V_{\max}} \frac{1 - e^{-V_{\max}/A_{\max}s}}{s} \right) \left(\frac{V_{\max}}{R_{\max}} \frac{1 - e^{-R_{\max}/V_{\max}s}}{s} \right) \\
 5^{\text{th}} \text{ order : } R(s) &= \frac{C_{\max}}{s} \frac{(1 - e^{-S_{\max}/C_{\max}s})(1 - e^{-J_{\max}/S_{\max}s})(1 - e^{-A_{\max}/J_{\max}s})(1 - e^{-V_{\max}/A_{\max}s})(1 - e^{-R_{\max}/V_{\max}s})}{s^5} \\
 &= \frac{R_{\max}}{s} \left(\frac{C_{\max}}{S_{\max}} \frac{1 - e^{-S_{\max}/C_{\max}s}}{s} \right) \left(\frac{S_{\max}}{J_{\max}} \frac{1 - e^{-J_{\max}/S_{\max}s}}{s} \right) \left(\frac{J_{\max}}{A_{\max}} \frac{1 - e^{-A_{\max}/J_{\max}s}}{s} \right) \left(\frac{A_{\max}}{V_{\max}} \frac{1 - e^{-V_{\max}/A_{\max}s}}{s} \right) \left(\frac{V_{\max}}{R_{\max}} \frac{1 - e^{-R_{\max}/V_{\max}s}}{s} \right) \\
 \vdots \\
 q^{\text{th}} \text{ order : } R(s) &= \frac{R_{\max}}{s} \prod_{i=1}^q \frac{1}{\tau_i} \frac{(1 - e^{-\tau_i s})}{s}
 \end{aligned}$$



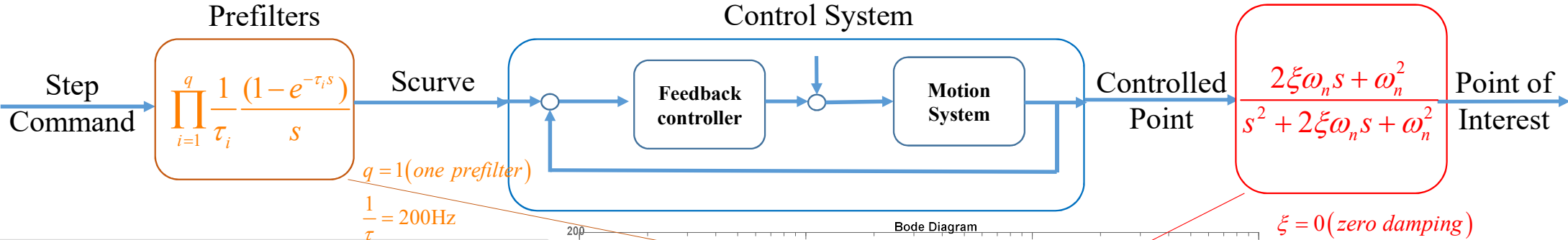
Conclusions:

- ① **S-curve:** Filtered step wave
- ② **Prefilter:** 1st order low-pass filter with specific frequency $(\frac{k}{\tau} \text{ Hz})$ suppression



3. Symmetric S-curve Planning

Parameter design: zero-pole cancellation Closed-loop Control System



Conclusion :

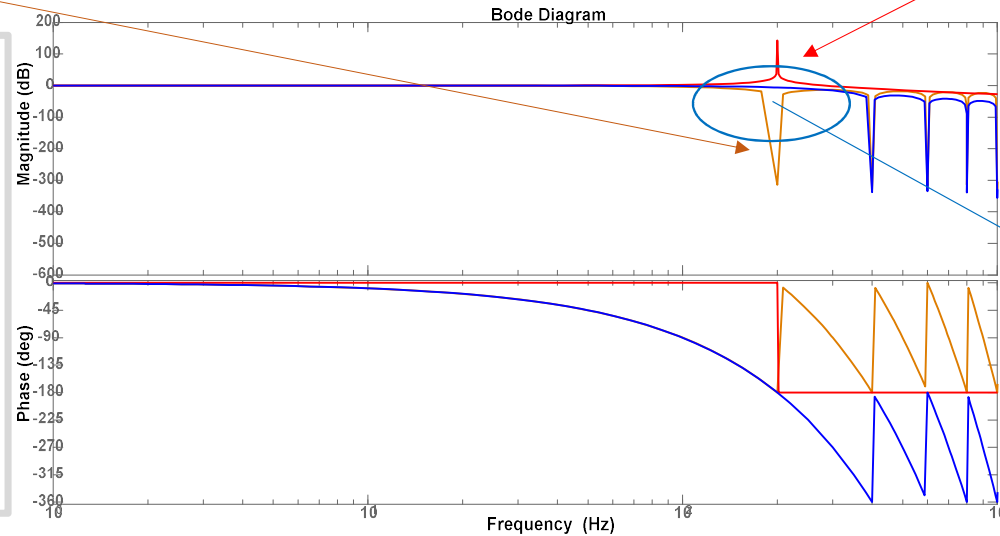
For 4th order S-curve,

$$\tau_i \in \left[\frac{J_{\max}}{S_{\max}}, \frac{A_{\max}}{J_{\max}}, \frac{V_{\max}}{A_{\max}}, \frac{R_{\max}}{V_{\max}} \right]$$

zero-pole cancellation: $\frac{k}{\tau_i} = f_{n,j}$

R_{\max}, V_{\max} are fixed - 1 zero is fixed

$A_{\max}, J_{\max}, S_{\max}$ can be tuned - 3 zeros can be designed to compensate poles of flexible modes



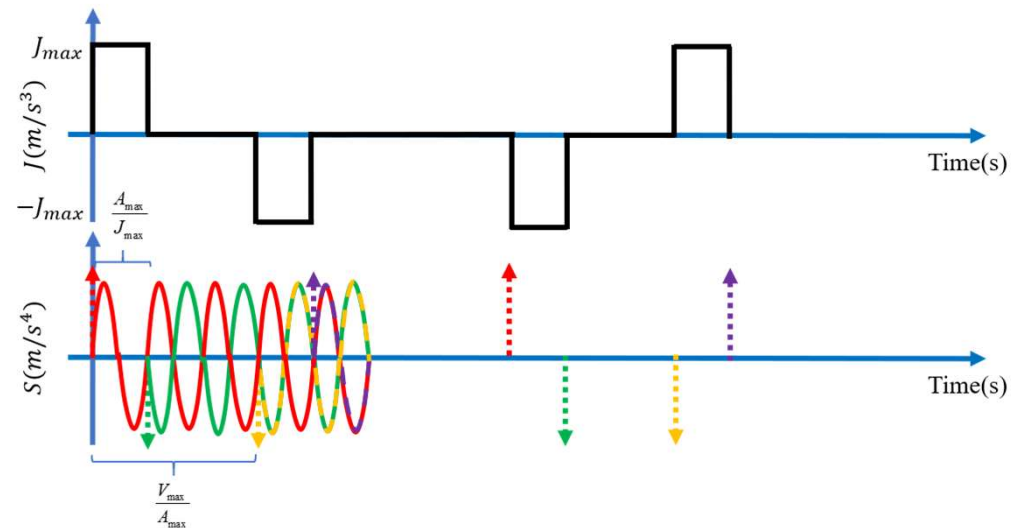
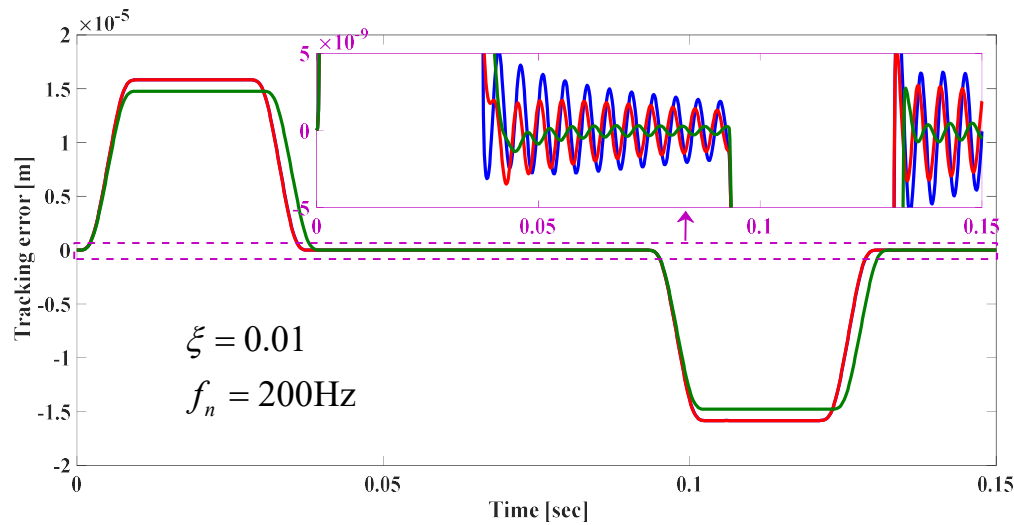
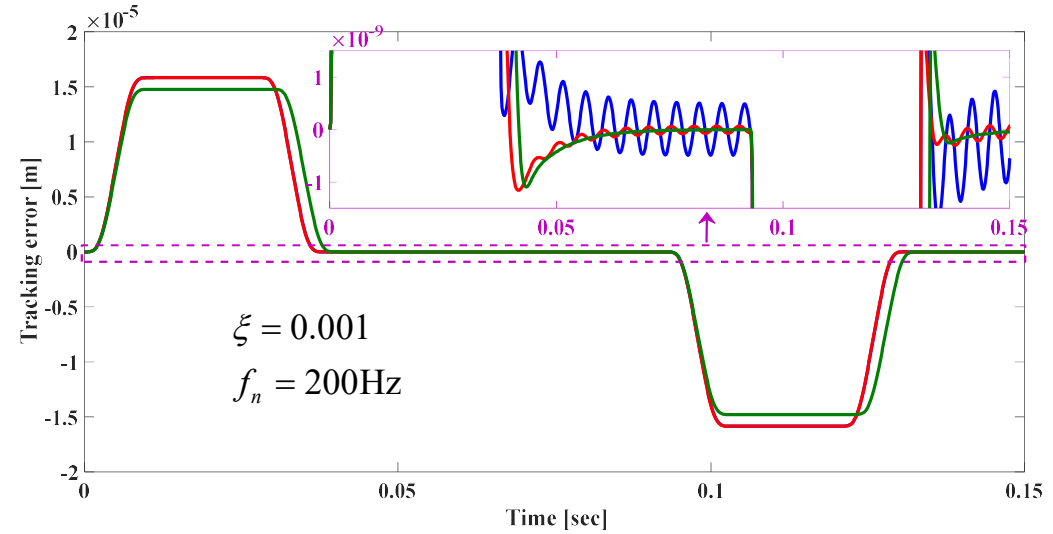
R_{\max}	V_{\max}	A_{\max}	J_{\max}	S_{\max}	C_{\max}
Die size	Throughput Sensor limit Actuator limit Light source	Throughput Actuator limit Residual vibration suppression	Throughput Residual vibration suppression	Throughput Residual vibration suppression	Throughput Residual vibration suppression

3. Symmetric S-curve Planning



Results & discussions

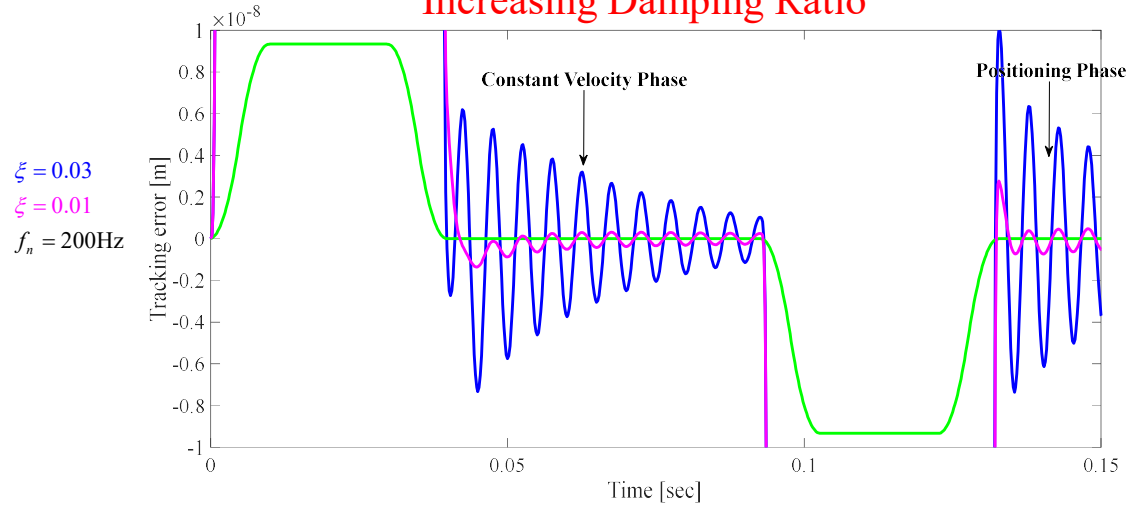
R_{\max}	V_{\max}	A_{\max}	J_{\max}	S_{\max}
0.065	0.7	25	4950	$J_{\max} \times f_n = 990000$
0.065	0.7	25	$A_{\max} \times f_n = 5000$	$J_{\max} \times f_n = 1000000$
0.065	0.7	$\frac{V_{\max} \times f_n}{6} = \frac{70}{3}$	$A_{\max} \times f_n = \frac{14000}{3}$	$J_{\max} \times f_n = \frac{2800000}{3}$



4. Asymmetric S-curve Planning

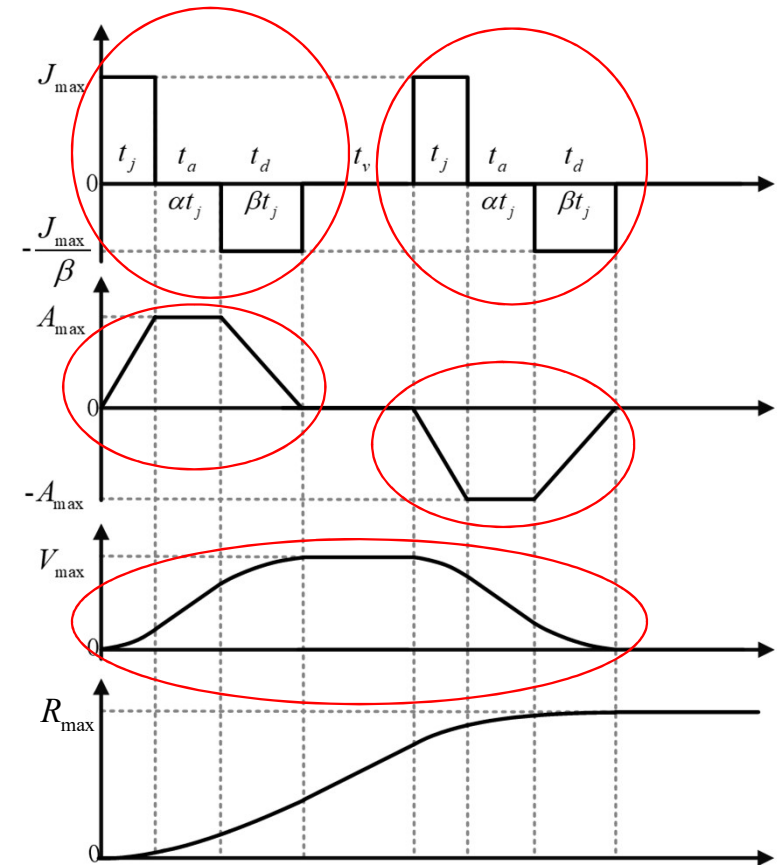
Representations of asymmetric S-curves

Increasing Damping Ratio

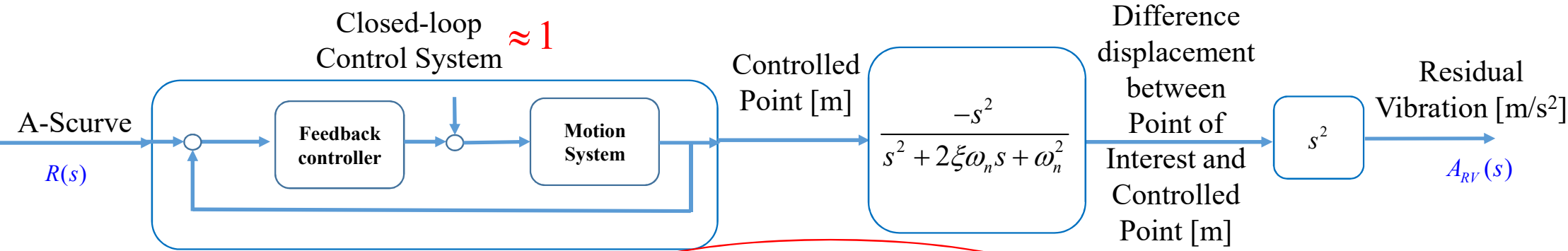


$$\left\{ \begin{array}{l} \text{Constant Velocity Phase: } R_c(s) = \frac{J_{\max}}{s} \frac{1 - e^{-\frac{t_m}{1+2\alpha+\beta}s} - \frac{1}{\beta} e^{-\frac{t_m(1+\alpha)}{1+2\alpha+\beta}s} + \frac{1}{\beta} e^{-\frac{t_m(1+\alpha+\beta)}{1+2\alpha+\beta}s}}{s^3} \\ \text{Positioning Phase: } R_p(s) = \frac{J_{\max}}{s} \left(1 - e^{-\frac{t_m}{1+2\alpha+\beta}s} - \frac{1}{\beta} e^{-\frac{t_m(1+\alpha)}{1+2\alpha+\beta}s} + \frac{1}{\beta} e^{-\frac{t_m(1+\alpha+\beta)}{1+2\alpha+\beta}s} \right) \left(1 - e^{-\frac{t_m(1+\alpha+\beta)+t_v}{1+2\alpha+\beta}s} \right) \end{array} \right.$$

$$\left\{ \begin{array}{l} t_m = 2 \frac{V_{\max}}{A_{\max}} \\ t_v = \frac{R_{\max}}{V_{\max}} - \frac{1+\alpha+\beta}{1+2\alpha+\beta} \frac{t_m}{2} \end{array} \right.$$



4. Asymmetric S-curve Planning



Constant Velocity Phase: $A_{RV-c}(s) = -\frac{J_{\max}}{s^2 + 2\xi\omega_n s + \omega_n^2} \left(1 - e^{-\frac{t_m}{1+2\alpha+\beta}s} - \frac{1}{\beta} e^{-\frac{t_m(1+\alpha)}{1+2\alpha+\beta}s} + \frac{1}{\beta} e^{-\frac{t_m(1+\alpha+\beta)}{1+2\alpha+\beta}s} \right)$

Positioning Phase: $A_{RV-p}(s) = -\frac{J_{\max}}{s^2 + 2\xi\omega_n s + \omega_n^2} \left(1 - e^{-\frac{t_m}{1+2\alpha+\beta}s} - \frac{1}{\beta} e^{-\frac{t_m(1+\alpha)}{1+2\alpha+\beta}s} + \frac{1}{\beta} e^{-\frac{t_m(1+\alpha+\beta)}{1+2\alpha+\beta}s} \right) \left(1 - e^{-\frac{t_m(1+\alpha+\beta)+t_v}{1+2\alpha+\beta}s} \right)$

$s_{jm} = -\xi\omega_n \pm \omega_d j$
 $\omega_d = \sqrt{1-\xi^2}\omega_n$

$$\left(1 - e^{-\frac{t_m}{1+2\alpha+\beta}s} - \frac{1}{\beta} e^{-\frac{t_m(1+\alpha)}{1+2\alpha+\beta}s} + \frac{1}{\beta} e^{-\frac{t_m(1+\alpha+\beta)}{1+2\alpha+\beta}s} \right) \Big|_{s=s_{jm}}$$

$$= 1 - e^{\frac{t_m \xi \omega_n}{1+2\alpha+\beta}} \cos\left(\frac{t_m \omega_d}{1+2\alpha+\beta}\right) - \frac{1}{\beta} e^{\frac{t_m(1+\alpha)\xi\omega_n}{1+2\alpha+\beta}} \cos\left(\frac{t_m(1+\alpha)\omega_d}{1+2\alpha+\beta}\right) + \frac{1}{\beta} e^{\frac{t_m(1+\alpha+\beta)\xi\omega_n}{1+2\alpha+\beta}} \cos\left(\frac{t_m(1+\alpha+\beta)\omega_d}{1+2\alpha+\beta}\right)$$

$$\pm \left(e^{\frac{t_m \xi \omega_n}{1+2\alpha+\beta}} \sin\left(\frac{t_m \omega_d}{1+2\alpha+\beta}\right) + \frac{1}{\beta} e^{\frac{t_m(1+\alpha)\xi\omega_n}{1+2\alpha+\beta}} \sin\left(\frac{t_m(1+\alpha)\omega_d}{1+2\alpha+\beta}\right) - \frac{1}{\beta} e^{\frac{t_m(1+\alpha+\beta)\xi\omega_n}{1+2\alpha+\beta}} \sin\left(\frac{t_m(1+\alpha+\beta)\omega_d}{1+2\alpha+\beta}\right) \right) j$$

$$= \text{Re}(\alpha, \beta) \pm \text{Im}(\alpha, \beta) j$$

zero-pole cancellation:
 $\text{Re}(\alpha, \beta) = 0$
 $\text{Im}(\alpha, \beta) = 0$

4. Asymmetric S-curve Planning

Solve the following equations with respect to α and β

$$\text{Re}(\alpha, \beta) = 1 - e^{\frac{t_m \xi \omega_n}{1+2\alpha+\beta}} \cos\left(\frac{t_m \omega_d}{1+2\alpha+\beta}\right) - \frac{1}{\beta} e^{\frac{t_m(1+\alpha)\xi\omega_n}{1+2\alpha+\beta}} \cos\left(\frac{t_m(1+\alpha)\omega_d}{1+2\alpha+\beta}\right) + \frac{1}{\beta} e^{\frac{t_m(1+\alpha+\beta)\xi\omega_n}{1+2\alpha+\beta}} \cos\left(\frac{t_m(1+\alpha+\beta)\omega_d}{1+2\alpha+\beta}\right) = 0$$

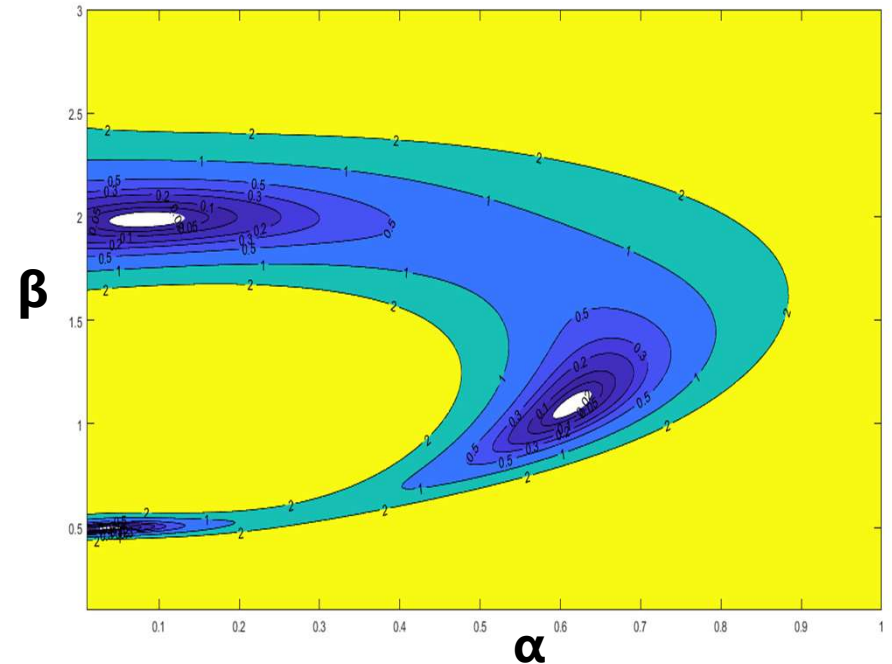
$$\text{Im}(\alpha, \beta) = \left(e^{\frac{t_m \xi \omega_n}{1+2\alpha+\beta}} \sin\left(\frac{t_m \omega_d}{1+2\alpha+\beta}\right) + \frac{1}{\beta} e^{\frac{t_m(1+\alpha)\xi\omega_n}{1+2\alpha+\beta}} \sin\left(\frac{t_m(1+\alpha)\omega_d}{1+2\alpha+\beta}\right) - \frac{1}{\beta} e^{\frac{t_m(1+\alpha+\beta)\xi\omega_n}{1+2\alpha+\beta}} \sin\left(\frac{t_m(1+\alpha+\beta)\omega_d}{1+2\alpha+\beta}\right) \right) = 0$$

Newton Iteration Method

$$\begin{cases} C|_{(\alpha, \beta)} \approx C|_{(\alpha_0, \beta_0)} + C'_\alpha|_{(\alpha_0, \beta_0)} \cdot (\alpha - \alpha_0) + C'_\beta|_{(\alpha_0, \beta_0)} \cdot (\beta - \beta_0) \\ S|_{(\alpha, \beta)} \approx S|_{(\alpha_0, \beta_0)} + S'_\alpha|_{(\alpha_0, \beta_0)} \cdot (\alpha - \alpha_0) + S'_\beta|_{(\alpha_0, \beta_0)} \cdot (\beta - \beta_0) \end{cases}$$

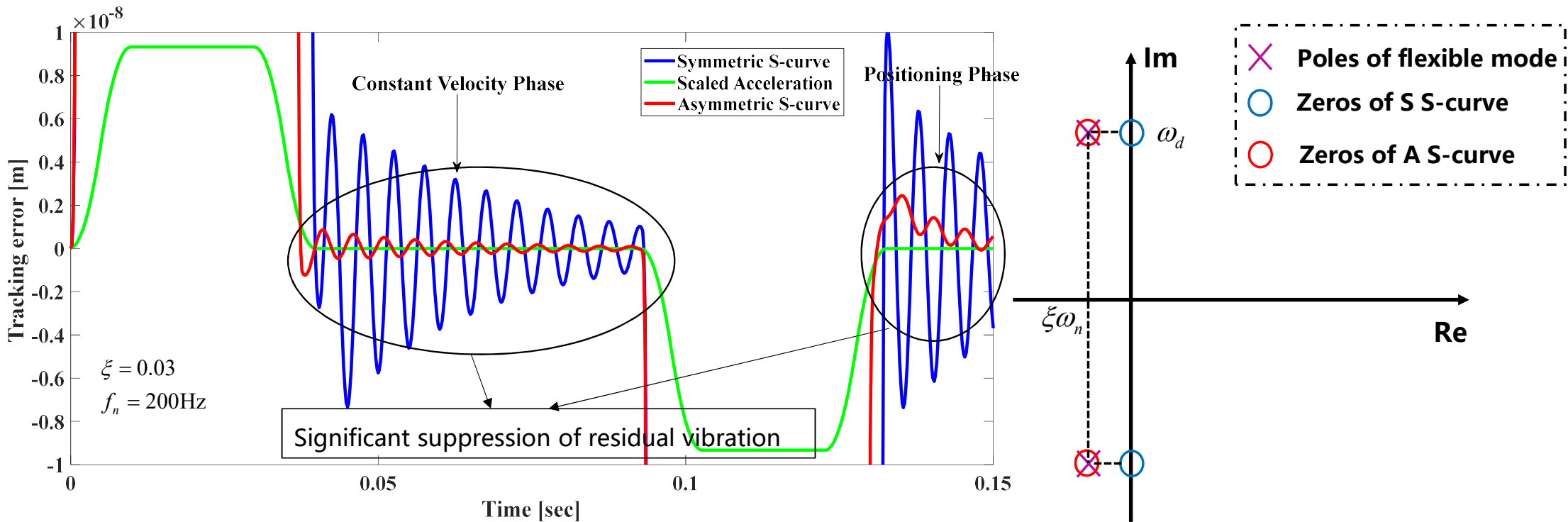
$$\begin{cases} C|_{(\alpha_0, \beta_0)} + C'_\alpha|_{(\alpha_0, \beta_0)} \cdot (\alpha - \alpha_0) + C'_\beta|_{(\alpha_0, \beta_0)} \cdot (\beta - \beta_0) = 0 \\ S|_{(\alpha_0, \beta_0)} + S'_\alpha|_{(\alpha_0, \beta_0)} \cdot (\alpha - \alpha_0) + S'_\beta|_{(\alpha_0, \beta_0)} \cdot (\beta - \beta_0) = 0 \end{cases}$$

$$\begin{cases} \alpha_{k+1} = \alpha_k + \frac{CS'_\beta - SC'_\beta}{S'_\alpha C'_\beta - C'_\alpha S'_\beta} \Big|_{(\alpha_k, \beta_k)} \\ \beta_{k+1} = \beta_k + \frac{SC'_\alpha - CS'_\alpha}{S'_\alpha C'_\beta - C'_\alpha S'_\beta} \Big|_{(\alpha_k, \beta_k)} \end{cases}$$

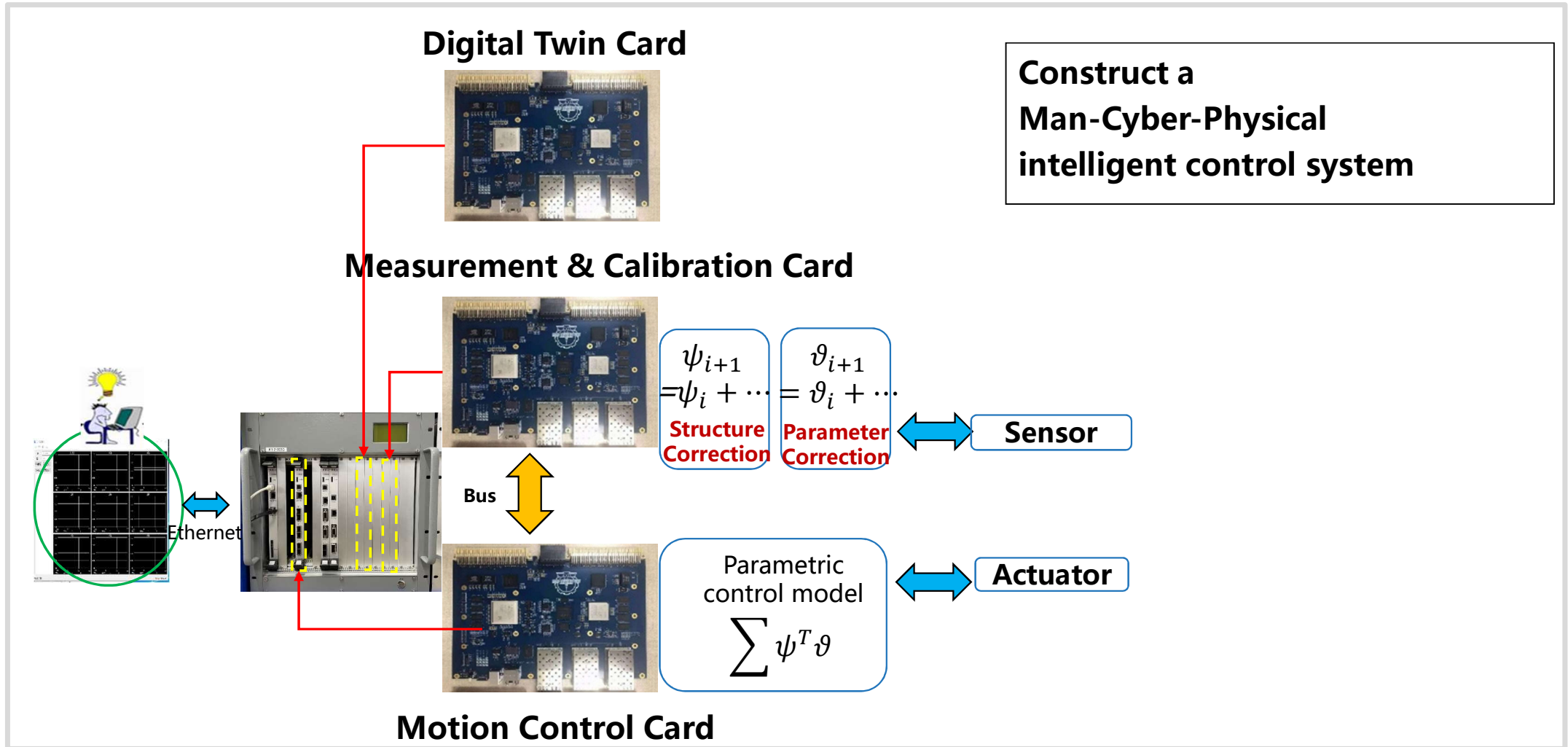


4. Asymmetric S-curve Planning

Results & discussions



5. Conclusion and Outlook



挑战尖端、仪器报国

哈工大功夫 传承者



Thank You!